



MS AF
Response Under 37 C.F.R. 1.116
Expedited Procedure Examining
Group: 3753
PATENT
3449-0184P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Kwang H. AN et al. Conf. No.: 2260
Appl. No.: 10/002,157 Group: 3753
Filed: December 5, 2001 Examiner: R. Krishnamurthy
For: VALVE PLATE STRUCTURE

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 2, 2004

Sir:

In response to the Examiner's final Office Action dated August 2, 2004, the due date having been extended one (1) month to December 2, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This Response includes Remarks.

12/03/2004 CNGUYEN 00000012 10002157

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